Fabrication of a bilayer with poly(*N*-isopropylacrylamide-*co*-acrylic acid) (pNIPAm-AAc) hydrogel and SU-8 photoresists

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Purpose

Here, we report a procedure for the surface treatment of SU-8 and fabrication of a functional bilayer of SU-8 and photodefineable pNIPAm-AAc thermally responsive hydrogel.

Materials

- SU-8 photoresist
- Jeffamine D230
- poly(*N*-isopropylacrylamide) (pNIPAm)
- *N*-isopropylacrylamide (NIPAm)
- acrylic acid
- *N*,*N*'-methylenebis(acrylamide)
- lithium phenyl(2,4,6-trimethylbenzoyl)phosphinate
- 1-butanol
- isopropanol

Procedure

A. Surface treatment of SU-8 for adhesion to pNIPAm-AAc hydrogel

- 1. Following patterning and development of SU-8 structures, submerge structures in pure Jeffamine D230 or a solution of Jeffamine in solvent.
- 2. Leave SU-8 soaking overnight at room temperature or, alternatively, heat the Jeffamine with SU-8 at 50 °C for 2-4 hours.
- 3. Rinse SU-8 thoroughly with isopropanol 3-5 times.
- 4. To confirm the presence of Jeffamine on SU-8, you may spot test a portion of SU-8 with a ninhydrin stain and heat gently. If Jeffamine is present, the stain should develop from colorless to purple or pink in color.

B. Formulation and patterning of pNIPAm-AAc photoresist

- 1. Into a vial, add 1-butanol (7.5 mL), pNIPAm (0.4 g), NIPAm (3 g), *N*,*N*'-methylenebis(acrylamide) (180 mg), and acrylic acid (0.3 mL).
- 2. Stir at room temperature with stir bar overnight or until fully dissolved.
- 3. Cover vial with foil if not working in yellow light conditions, add lithium phenyl(2,4,6-trimethylbenzoyl)phosphinate (30 mg), and stir until dissolved.
- 4. Dropcast or spin coat resist onto Jeffamine-treated SU-8 and expose with 365 or 405 nm light at 15 mW/cm² for 60 s.
- 5. Develop and rinse with water or alcohols such as ethanol or isopropanol.